

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerome M. Eldridge et al.

Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW ASYMMETRICAL
TUNNEL BARRIER INTERPOLY INSULATORS

Docket No. 1303.045US1

Filed: February 20, 2002

Examiner: Tu-Tu Ho

Serial No.: 10/081,818

Due Date: January 15, 2005

Group Art Unit: 2818

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ A return postcard.

☒ Amendment and Response Under 37 CFR 1.111 (8 Pages).

☐ A Communication Concerning Related Applications (2 pgs.).

☒ A Supplemental Information Disclosure Statement (2 pgs.), and Form 1449 (1 pg.).

☒ A check in the amount of \$180.00 to cover the fee for consideration of Information Disclosure Statement under 97(c).

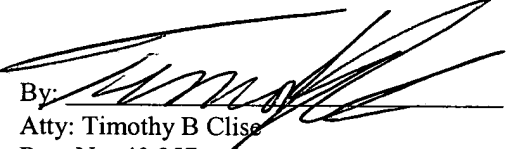
☒ Terminal Disclaimer (3 pgs.).

☒ Authorization to charge Deposit Account in the amount of \$130.00 to cover the fee for submission of Terminal Disclaimer.

If not provided for in a separate paper filed herewith, Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

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By: 
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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 14 day of January, 2005.

Name

KACIA LEE

Signature

Kacia Lee

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)